

Nano4me.org Video Download

ESC 212: Basic Nanotechnology Processes

Unit 3: An Introduction to Wet Etching



Lecture

Length: 1:02:10 This

video will cover:

- Etch Methods Definitions
- Common Etch Terms
- Review of Isotropic vs. Anisotropic Etching

Thank You For Watching!

What did you think? [Email](#) Bob Ehrmann with your feedback.

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